Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	2	("6191518").PN.	USPAT; USOCR; JPO; DERWENT	OR	OFF	2005/10/27 10:08
S2	1	S1 and parallel	USPAT; JPO; DERWENT	OR	ON	2005/11/15 12:44
S3	1	S1 and perpendicular	USPAT; JPO; DERWENT	OR	ON	2005/10/27 10:10
S4	8	("5043043" | "5072288" | "5428259" | "5512374" | "5583736" | "5635640" | "5784189" | "5812362").PN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/10/27 11:26
S5	7	("4381672" | "4754185" | "4943750" | "5013954" | "5015906" | "5043043" | "5055731").PN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/10/27 11:37
S6	38	("5428259").URPN.	USPAT	OR	ON	2005/10/27 11:39
S7	8	("5043043" | "5072288" | "5428259" | "5512374" | "5583736" | "5635640" | "5784189" | "5812362").PN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/10/27 11:45
S8	217544	mov$4 with station$4	USPAT; JPO; DERWENT	OR	ON	2005/10/27 11:46
S9	66614	movable with stationary	USPAT; JPO; DERWENT	OR	ON	2005/10/27 11:47
S10	4	S6 and S9	USPAT; JPO; DERWENT	OR	ON	2005/10/27 11:46
S11	1135	(movable adj (element or electrode)) with (stationary adj (element or electrode))	USPAT; JPO; DERWENT	OR	ON	2005/10/27 11:48
S12	36	S11 and microstructure	USPAT; JPO; DERWENT	OR	ON	2005/10/27 11:48
S13	7	(movable adj (element or electrode)) with (stationary adj (element or electrode)) with microstructure	USPAT; JPO; DERWENT	OR	ON	2005/10/27 11:50
S14	10	(movable adj (element or electrode)) with (stationary adj (element or electrode)) with polysilicon	USPAT; JPO; DERWENT	OR	ON	2005/10/27 11:50
S15	1	(US-5428259-$).did.	USPAT	OR	ON	2005/10/27 11:55

S16	1	S15 and parallel	USPAT; JPO; DERWENT	OR	ON	2005/10/27 11:56
S17	2	("6191518").PN.	USPAT; USOCR; JPO; DERWENT	OR	OFF	2005/11/15 12:44
S18	2	S17 and semiconductor	USPAT; JPO; DERWENT	OR	ON	2005/11/15 12:44
S19	571	(movable near element) with (stationary near element)	USPAT; JPO; DERWENT	OR	ON	2005/11/15 13:37
S20	775	(movable near electrode) with (stationary near electrode)	USPAT; JPO; DERWENT	OR	ON	2005/11/15 13:17
S21	14	S19 and S20	USPAT; JPO; DERWENT	OR	ON	2005/11/15 13:17
S22	7	S21 and microstructure	USPAT; JPO; DERWENT	OR	ON	2005/11/15 13:32
S23	20	S19 and microstructure	USPAT; JPO; DERWENT	OR	ON	2005/11/15 13:21
S24	8	("5013693" | "5025346" | "5029805" | "5259247" | "5403665" | "5512374" | "5838351" | "5971355").PN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/11/15 13:30
S25	32	Suzuki-Kenichiro.in.	US-PGPUB; USPAT; USOCR	OR	ON	2005/11/15 13:30
S26	2	S19 and S25	US-PGPUB; USPAT; USOCR	OR	ON	2005/11/15 13:30
S27	33407	microstructure	USPAT; JPO; DERWENT	OR	ON	2005/11/15 13:32
S28	152	microstructure near polysilicon	USPAT; JPO; DERWENT	OR	ON	2005/11/15 13:35
S29	571	(movable near element$) with (stationary near element$)	USPAT; JPO; DERWENT	OR	ON	2005/11/15 13:32
S30	640	(movable near element$) same (stationary near element$)	USPAT; JPO; DERWENT	OR	ON	2005/11/15 13:34

S31	8	S28 and S30	USPAT; JPO; DERWENT	OR	ON	2005/11/15 13:33
S32	97	(movable near element$) same (stationary near element$)	US-PGPUB	OR	ON	2005/11/15 13:34
S33	184	microstructure same polysilicon	US-PGPUB	OR	ON	2005/11/15 13:36
S34	0	S32 and S33	US-PGPUB	OR	ON	2005/11/15 13:35
S35	4	S32 and polysilicon	US-PGPUB	OR	ON	2005/11/15 13:35
S36	2811	microstructure same (polysilicon or metal$3)	US-PGPUB	OR	ON	2005/11/15 13:36
S37	1	S32 and S36	US-PGPUB	OR	ON	2005/11/15 13:36
S38	2	(movable near element) with (stationary near element) same polysilicon	USPAT; JPO; DERWENT	OR	ON	2005/11/15 13:37
S39	3	(movable near element) same (stationary near element) same polysilicon	USPAT; JPO; DERWENT	OR	ON	2005/11/15 13:51

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IEE JNL	IEE Journal or Magazine
IEEE CNF	IEEE Conference Proceeding
IEE CNF	IEE Conference Proceeding
IEEE STD	IEEE Standard

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